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PATENT & TRADEMARK OFFICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of	:	**Confirmation No. 6454**
Shigeru YOKOI et al.	:	Attorney Docket No. 2003_1452A
Serial No. 10/681,141	:	Group Art Unit 1751
Filed October 9, 2003	:	Examiner Gregory E. Webb
CLEANING LIQUID USED IN PHOTO-LITHOGRAPHY AND A METHOD FOR TREATING SUBSTRATE THEREWITH		**Mail Stop: Amendment**

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated July 27, 2005, the period for response having been extended for three months by the attached petition, please amend the present application as follows: